



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Hiroshi YOSHIDA

Group Art Unit: 2812

Serial No.: 10/501,080

Filed: December 14, 2004

Confirmation No.: 3317

For: METHOD FOR GETTERING TRANSITION METAL IMPURITIES IN
SILICON CRYSTAL

Attorney Docket Number: 042440

Customer Number: 38834

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §1.97(b)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: March 9, 2005

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. This paper is being filed within the time periods set forth in 37 C.F.R. §1.97(b). A copy of each non-U.S. document is enclosed herewith.

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Respectfully submitted,

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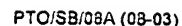
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Complete if Known

Application Number	10/501,080
Filing Date	December 14, 2004
First Named Inventor	Hiroshi YOSHIDA
Art Unit	2812
Examiner Name	Not Yet Assigned
Attorney Docket Number	042440

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U. S. PATENT DOCUMENTS

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